**Attorney Docket No.: P-8503-US** 

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): ZAIT, Eitan, et al. Examiner: FRASER, Stewart A.

Serial No.: 10/564,972 Group Art Unit: 2625

Filed: August 1, 2006 Confirmation No. 7182

Title: METHOD FOR CORRECTING CRITICAL DIMENSION VARIATIONS IN

PHOTOMASKS

## **Mail Stop RCE**

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

## **AMENDMENT**

Sir:

This Amendment is being filed in response to the final Office action dated August 11, 2009 issued by the United States Patent and Trademark Office in connection with the above-identified Application. A response to the August 11, 2009 final Office action was due November 11, 2009. Applicants are concurrently filing a Petition for a Two-Month Extension of Time, including the required fee. Therefore, a response is due January 11, 2009. Accordingly, this Amendment is being timely filed. A request for continued examination is also concurrently being filed, including the required fee.

Kindly amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page **5** of this paper.